

Docket No.: IPA-007

## JC17 Rec'd PCT/PTO 29 APR 2005

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Inventor(s): Akira NAKASHIMA et al.

Confirmation No.

U.S. Patent Application No.: Not yet assigned

Group Art Unit: Not yet assigned

Filed: herewith

For:

COATING LIQUID FOR FORMING AMORPHOUS SILICA-BASED COATING

FILM WITH LOW DIELECTRIC CONSTANT AND METHOD FOR PREPARING

THE SAME

## **INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Respectfully submitted,

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## INFORMATION DISCLOSURE CITATION IN AN APPLICATION

ATTY. DOCKET NO.
IPA-007

APPLICANT
Akira NAKASHIMA et al.

FILING DATE

GROUP

(PTO-1449)			herewith				
		<del></del>	PATENT DOCUMENTS				
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS		ING ATE
	2002/0060364 A1	05/23/2002	YAN et al			<del> </del>	
	6 451 436 B1	09/17/2002	KOMATSU et al			†	
	6 639 015 B1	10/28/2003	NAKASHIMA et al				
		FOREIG	N PATENT DOCUMENTS			: :57	-1: Tan
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Transl Yes	No No
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	OTHER	ART (Including	g Author, Title, Date, Pertinen	 it Pages, Etc	:))'		
	Patent Abstract of J CATALYST & CH		on No.: 2002-030249; Publicat TD	tion Date: 0	1/31/2002; Ap	plicant:	•
	Patent Abstract of Japan; Publication No.: 2000-349083; Publication Date: 12/15/2000; Applicant: NIPPON ASM KK						
	Patent Abstract of Japan; Publication No.: 09-315812; Publication Date: 12/09/1997; Applicant: CATALYST & CHEM IND CO LTD						
	I						
EXAMINER			DATE CONSIDERE	D			

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.